

Electronic Acknowledgement Receipt

EFS ID:	1086797
Application Number:	10555141
Confirmation Number:	2898
Title of Invention:	Method for texturing surfaces of silicon wafers
First Named Inventor:	Alexander Hauser
Customer Number:	832
Filer:	Anthony Niewyk/Michelle Davis
Filer Authorized By:	Anthony Niewyk
Attorney Docket Number:	RAC0082
Receipt Date:	21-JUN-2006
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Application Type:	U.S. National Stage under 35 USC 371
International Application Number:	

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment - After Non-Final Rejection	RAC0082AMEND.pdf	101834	no	5

Warnings:**Information:****Total Files Size (in bytes):**

101834

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.